

## ABSTRACT

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A<sup>1</sup> The present invention provides reduced production cost in a method for manufacturing an organic EL device including a step of forming a light-emitting layer having a predetermined pattern by an ink-jet method. The method achieves this objective by not forming a bank which surrounds an area in a substrate surface other than an area at which a light-emitting layer is formed. A solution-repellent treatment is performed so that a droplet of a liquid containing a light-emitting material has a contact angle of 15° to 90° with respect to the substrate surface immediately before formation of the light-emitting layer. Accordingly, a fluorine containing layer (a layer composed of a material containing fluorine) is formed. Between a step of forming the light-emitting layer and a step of forming a cathode, a step of forming a hole blocking layer over the entire surface of the substrate is performed.

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